

**Fig. 1.** Micrographs of Piccolo, a  $32 \times 32$  SPAD array with photosensitive area on the top section, highlighted in red (left) [41,42] – see also Fig. 8 (center); SwissSPAD2  $512 \times 512$ , a gated SPAD imager with 4 pixels shown in the inset (center, featuring round SPAD active areas in this case) [45]; Detail of LinoSPAD2, a  $512 \times 1$  linear SPAD array with top alignment cross integrated in the metal stack (right).

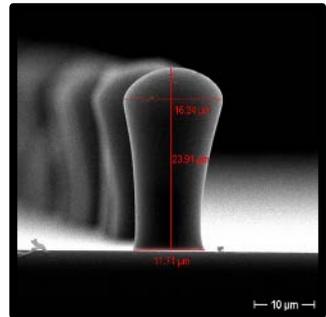
Guillaume Basset  
 Focus Area Manager Photonics  
 Group Leader Micro Nano Optics

SwissPhotonics Workshop  
 March 21<sup>st</sup> 2024

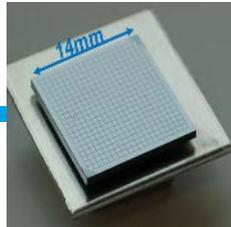
PHOTONICS INTEGRATION AT CSEM



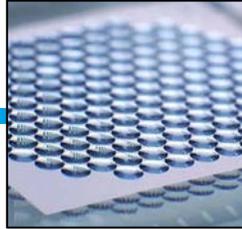
# PHOTONICS AT CSEM



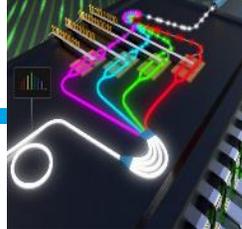
Components



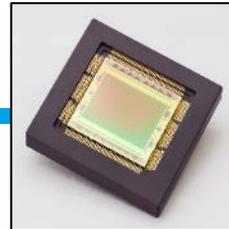
MOEMS



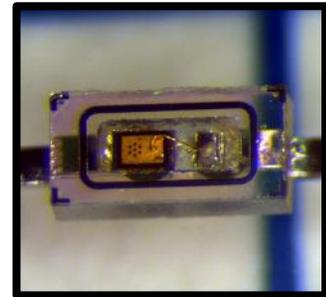
MLAs on imagers



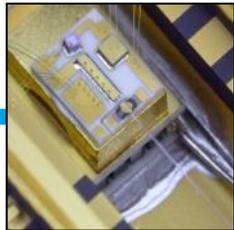
LNOI PICs



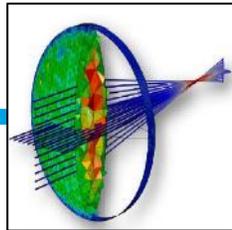
Imaging sensors



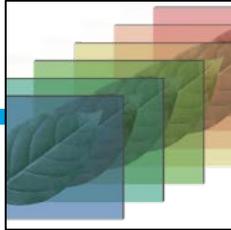
Technologies



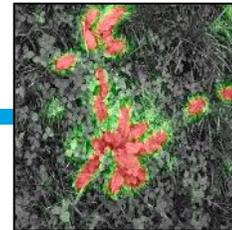
PIC Design,  
Testing, Consulting  
for Integration



Optical Design:  
Zemax, Comsol,  
LightTools, FDTD



Metrology & Vision,  
Multispectral  
Imaging



ML & AI



Systems



Lasers



Cameras



Lidar



Sensing Systems,  
Readout Modules

Many industrial partners & EU/global Partnerships:



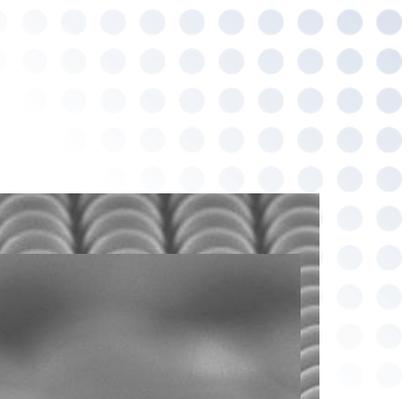
PHOTONICS PUBLIC PRIVATE PARTNERSHIP



## 2 INTEGRATION HIGHLIGHTS

1. MICRO-OPTICS INTEGRATION ON-CHIPS:  
MICROLENS ARRAYS (MLA)
2. MICRO-OPTICS INTEGRATION ON-CHIPS:  
PHOTONICS INTEGRATED CIRCUITS

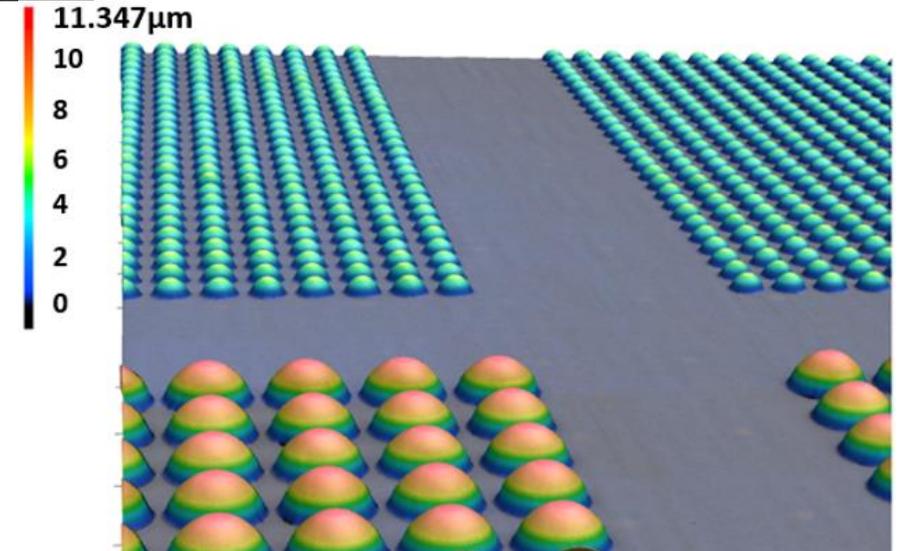
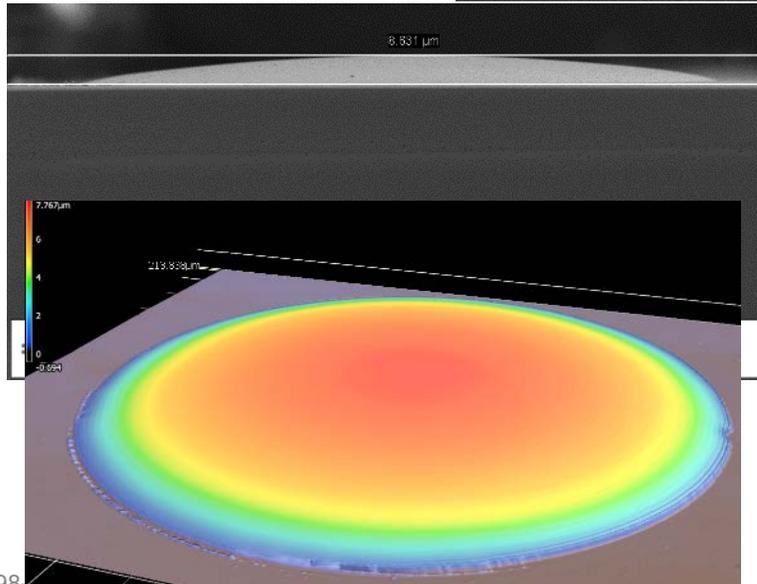
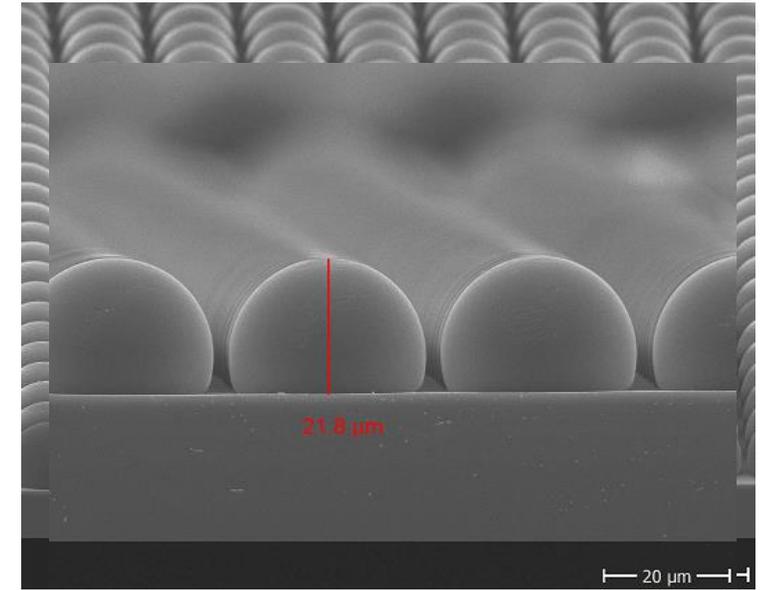
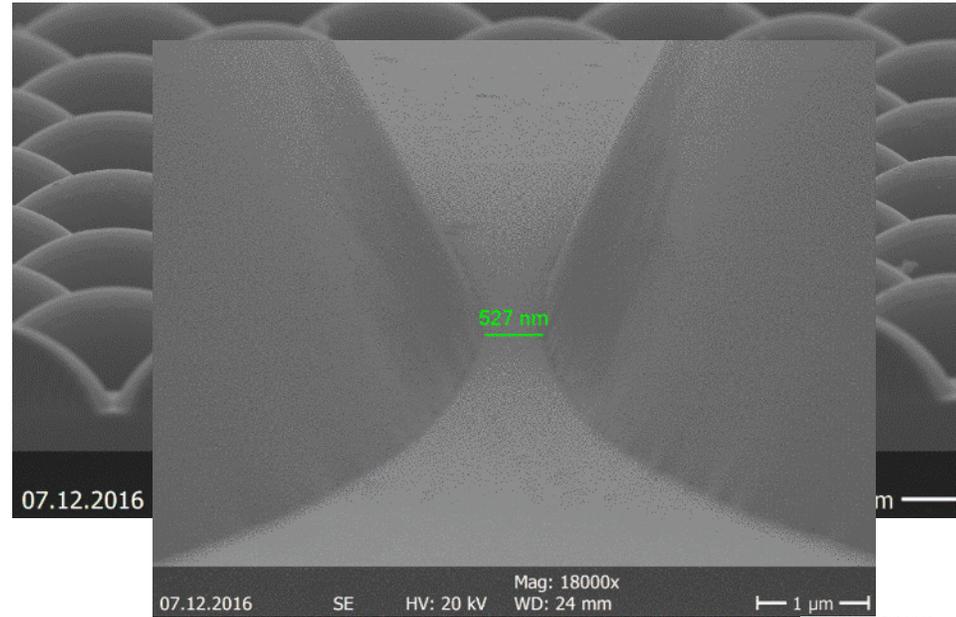
# FABRICATING ADVANCED MICROLENS ARRAYS



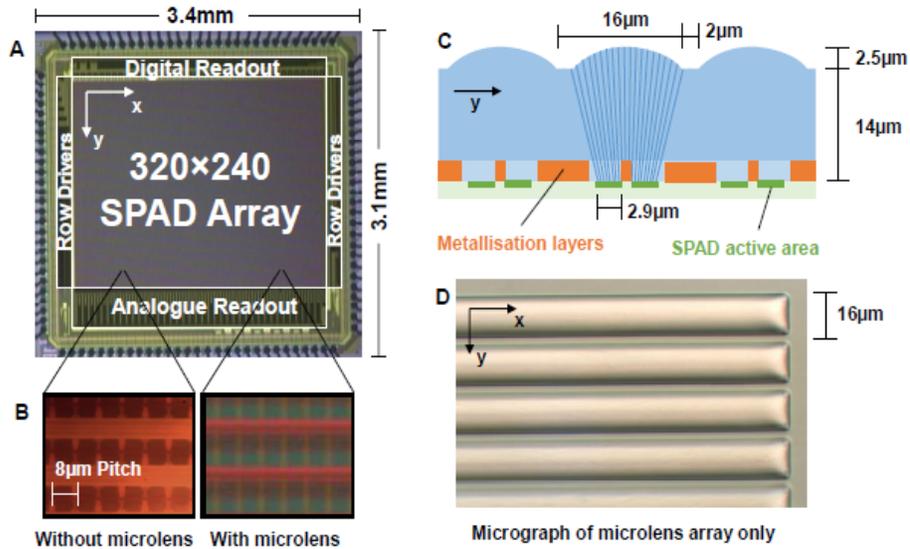
Microlenses from 2 microns to 2 mm

- ✓ Nearly gapless MLA
- ✓ High aspect ratio MLA
- ✓ Ultra flat MLA
- ✓ Multi height/Sag MLA

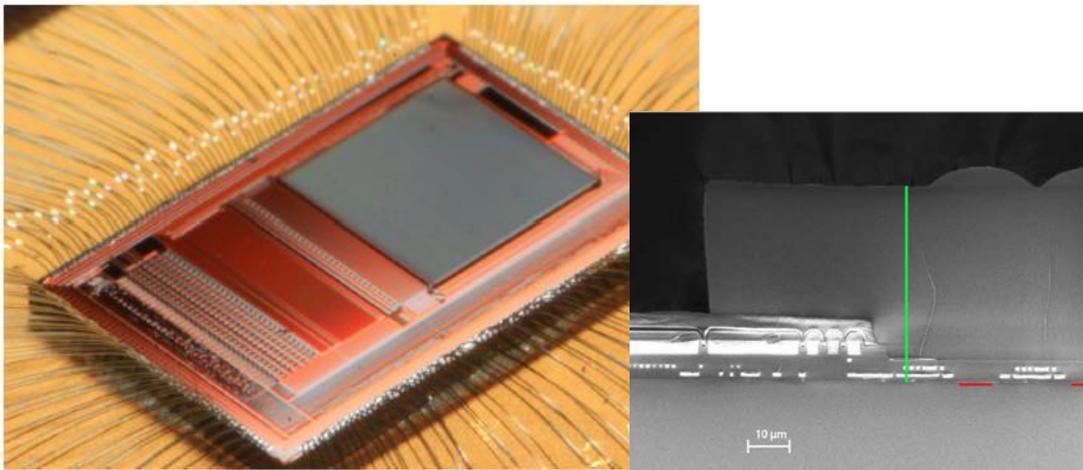
If not good enough, we make the micro-optics freeform



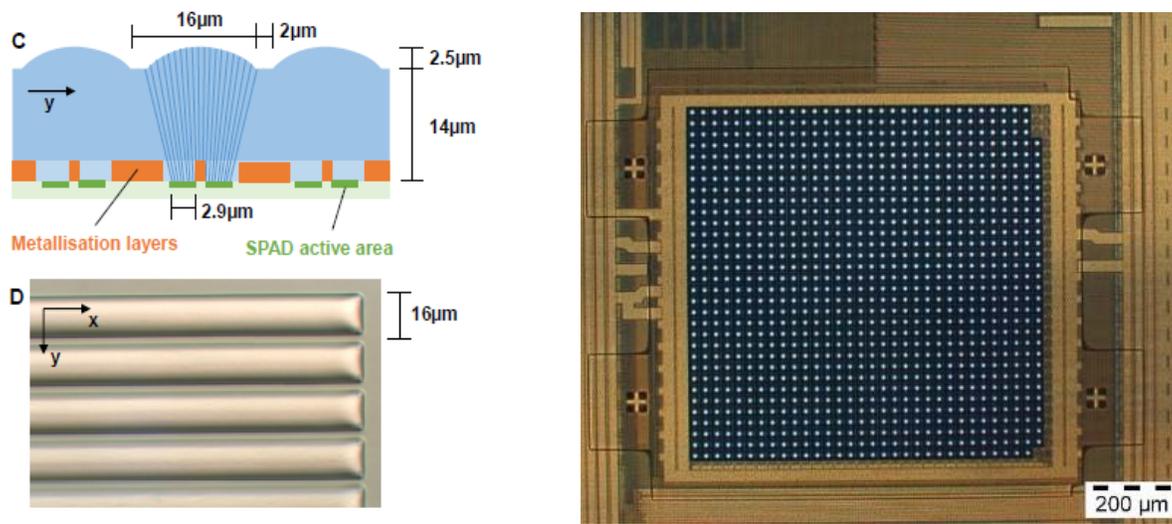
# MICRO-OPTICS INTEGRATED ON IMAGERS



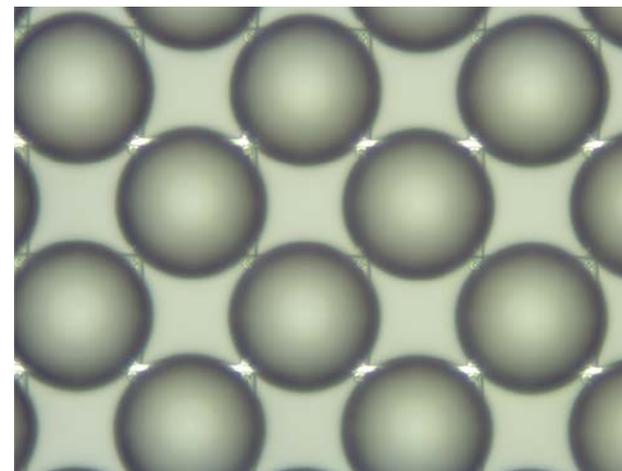
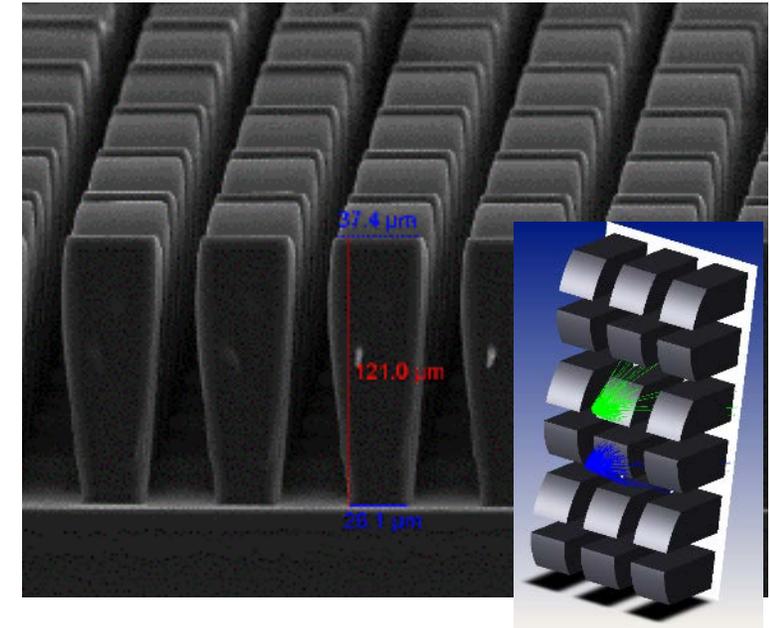
I. Gyongy et al., *Optics Express*, **26**, 2280-2291 (2018)



J. Mata Pavia et al., *Opt. Express* **22**, 4202-4213 (2014)



I. M. Antolovic et al., *Quantum Sensing and Nano Electronics and Photonics XVI*, **10926**, 359–365 (2019)



C. Tripl et al., *Nucl. Instrum. Methods Phys. Res., A* **1040**, 167216, (2022)

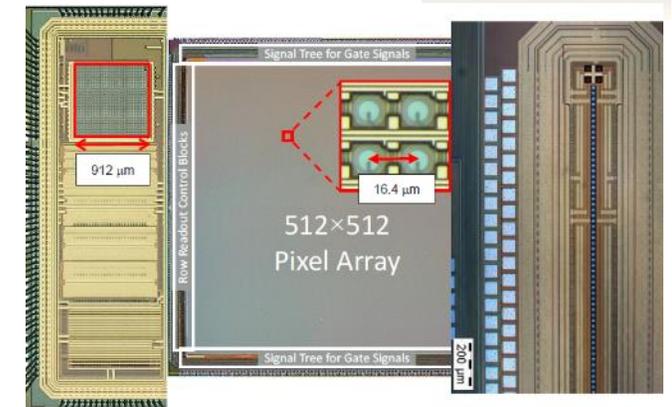
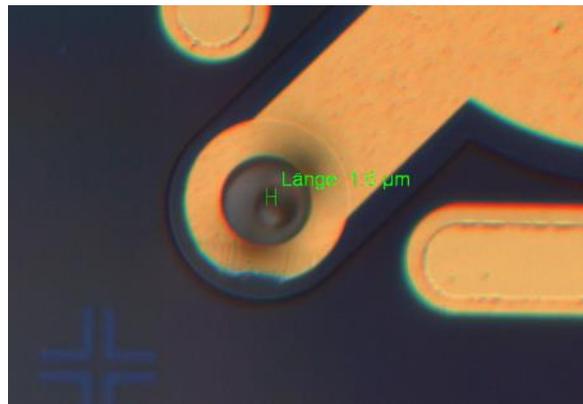
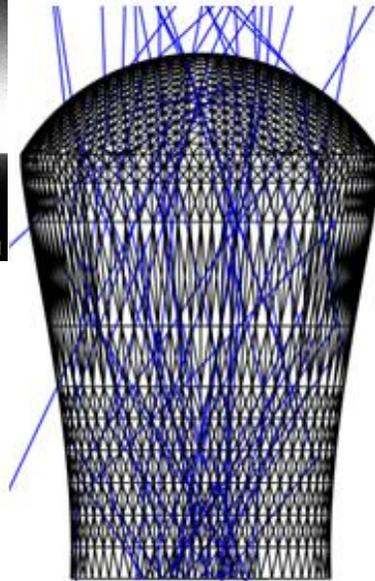
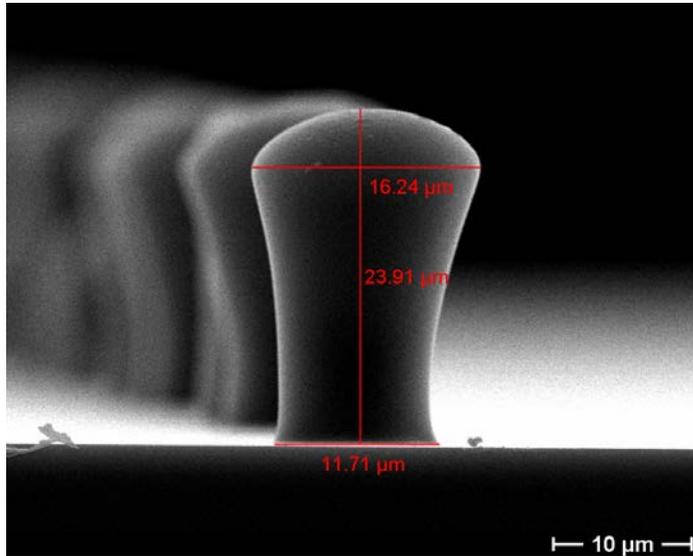


Fig. 1. Micrographs of Piccolo, a  $32 \times 32$  SPAD array with photosensitive area on the top section, highlighted in red (left) [41,42] – see also Fig. 8 (center); SwissSPAD2  $512 \times 512$ , a gated SPAD imager with 4 pixels shown in the inset (center, featuring round SPAD active areas in this case) [45]; Detail of LinoSPAD2, a  $512 \times 1$  linear SPAD array with top alignment cross integrated in the metal stack (right).

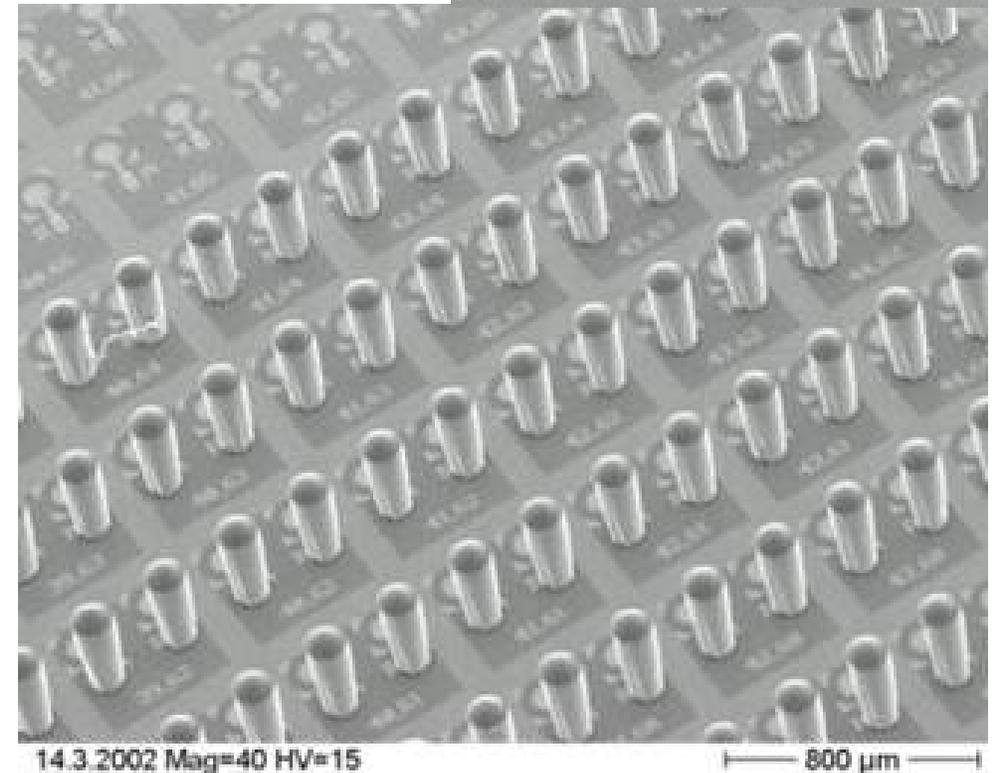
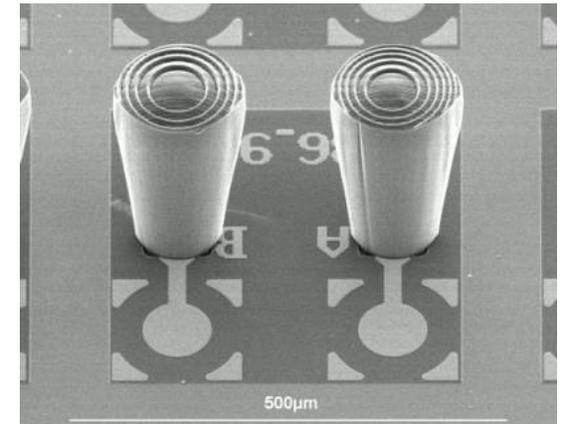
C. Bruschini et al., *Optics Express*, **31** (13), 21935-21953 (2023)

# MICRO-OPTICS INTEGRATED ON LIGHT EMITTERS

Micro-LEDs beam-shaping



VECSEL beam-shaping



## 2 INTEGRATION HIGHLIGHTS

1. MICRO-OPTICS INTEGRATION ON-CHIPS:  
MICROLENS ARRAYS (MLA)

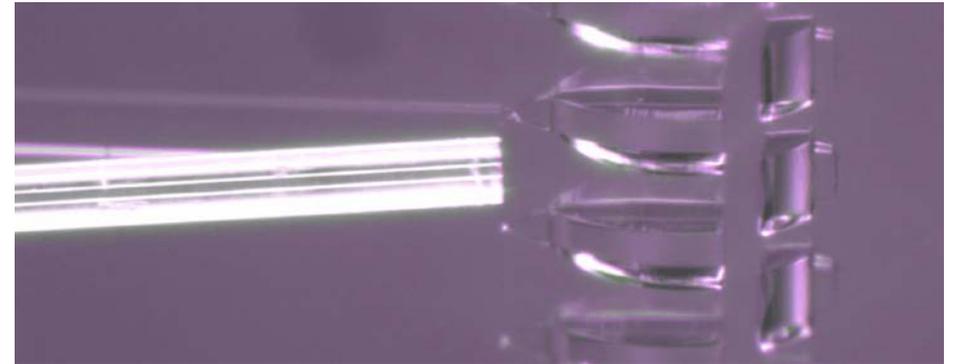
2. MICRO-OPTICS INTEGRATION ON  
PHOTONICS INTEGRATED CIRCUITS

# FIBER ARRAY HOLDER FOR PASSIVE ALIGNMENT MICRO-OPTICAL INTERCONNECT

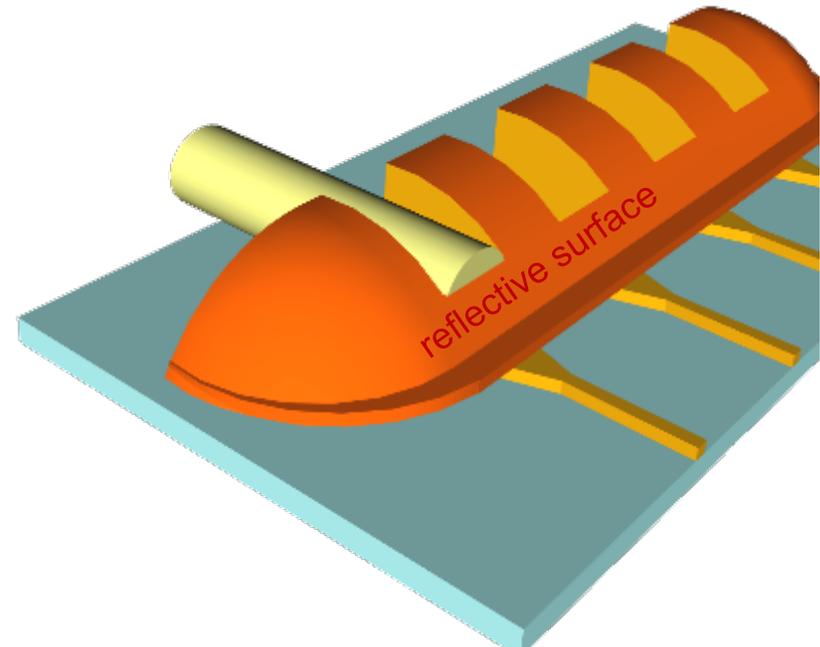
Wafer-scale micro-imprinted micro-structures for fiber passive alignment walls/funnels and beam redirecting

- Passive fiber array coupling using integrated self-alignment structures
- Ultra-smooth reflecting surfaces using total internal reflection (TIR) and based on a photoresist reflow process
- Operational for visible and all standard telecommunication optical fibers (SM and MM, 850-1650nm)
- Redirection angle adjustable:  
 $\alpha = 70 - 110$  degree

Plug & Play passive fiber assembly using the wafers-scale-alignment structures

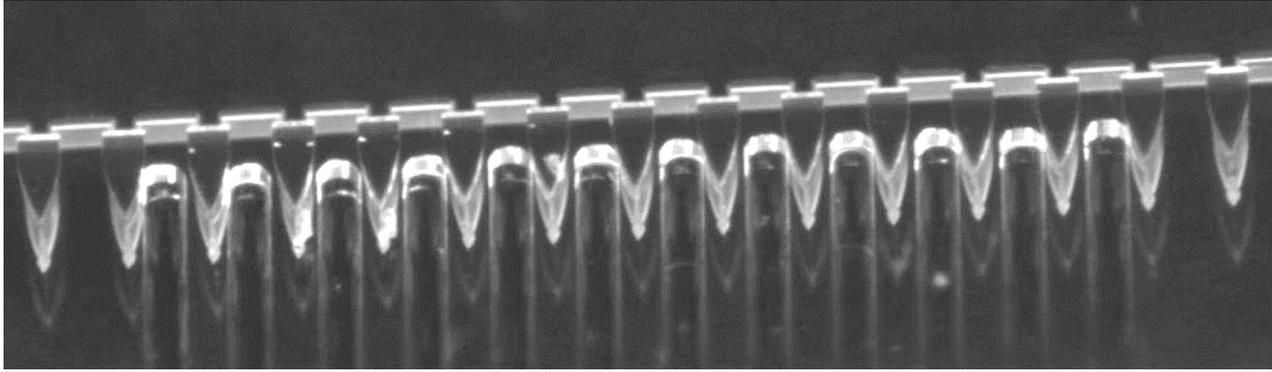


For single fiber, multi-fiber, fiber ribbons

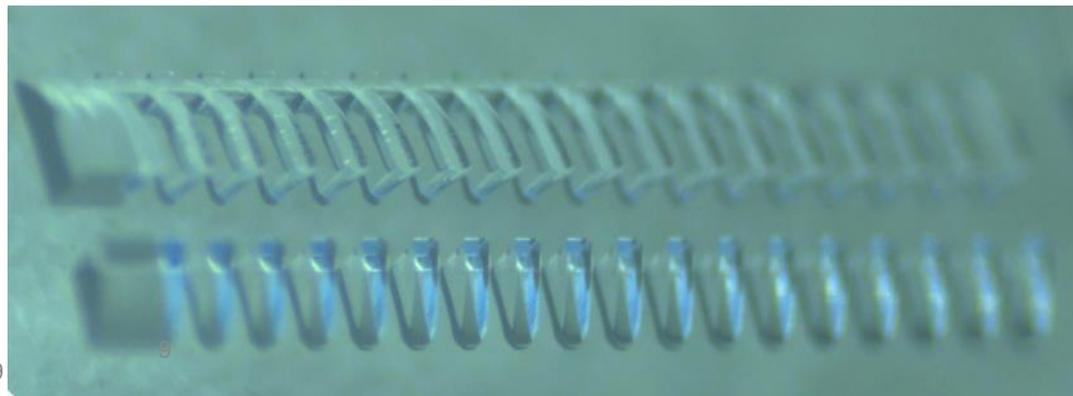
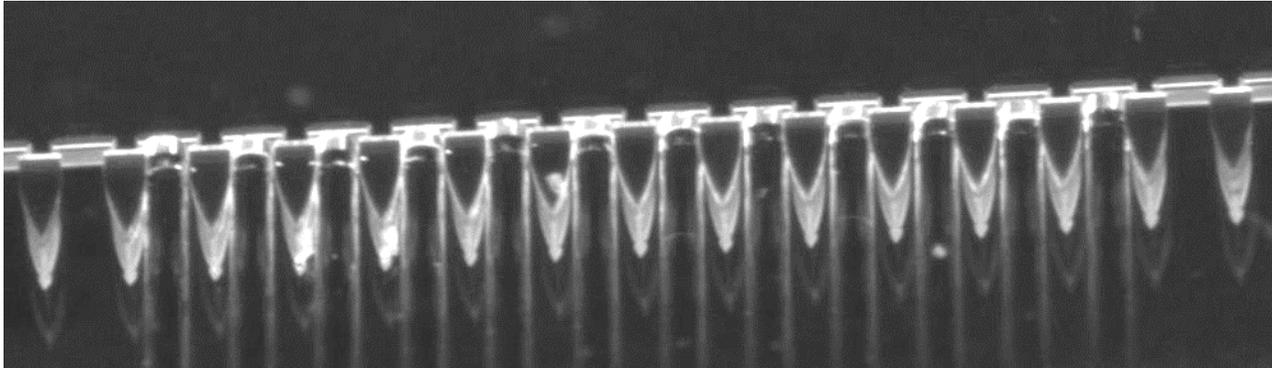


# PLUG AND PLAY FIBER ASSEMBLING

Partly inserted fiber array

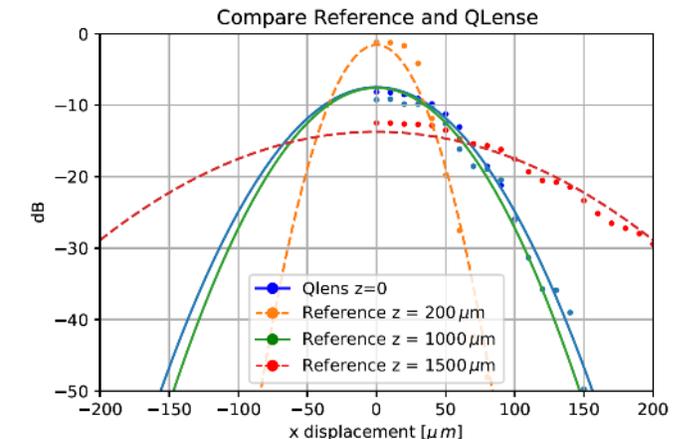
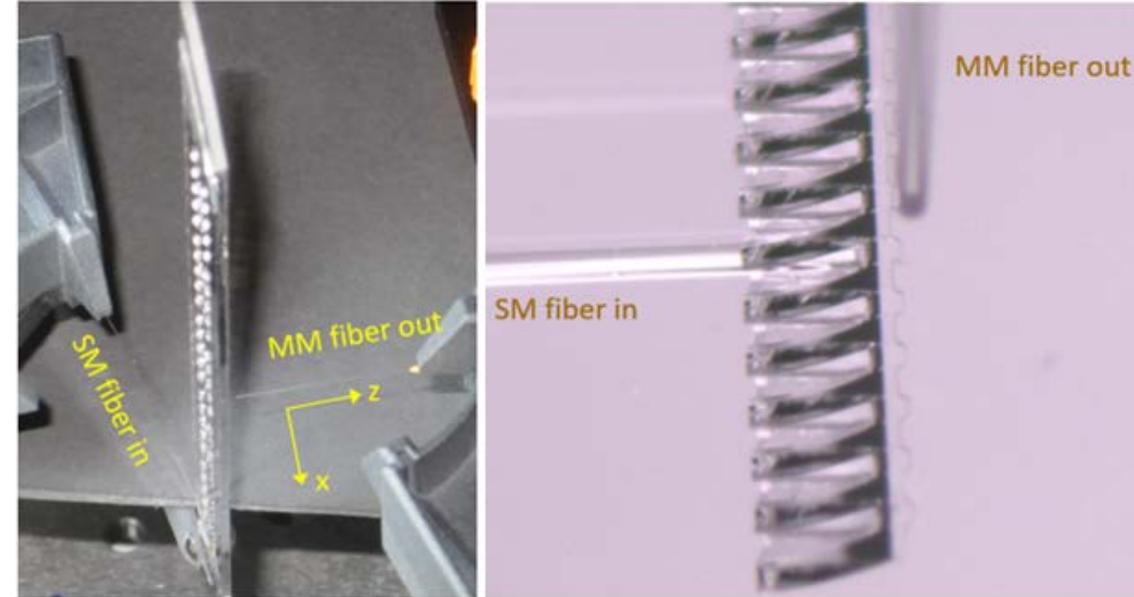


12<sup>er</sup> fiber ribbon fully inserted against the reflecting element



Different functions are possible: funnels, stress releases, waveguide protection / extra cladding...

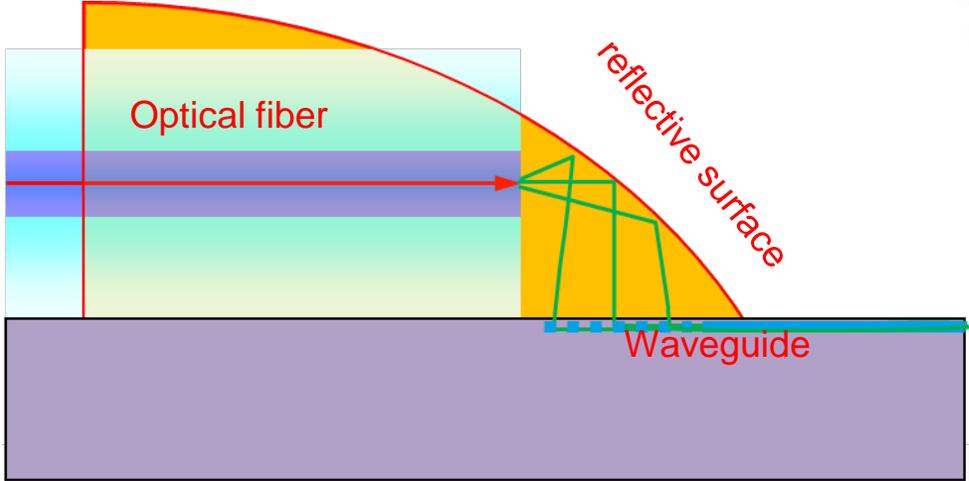
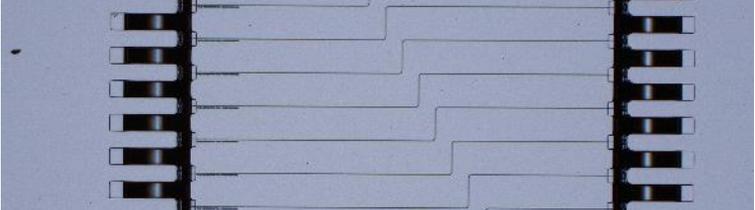
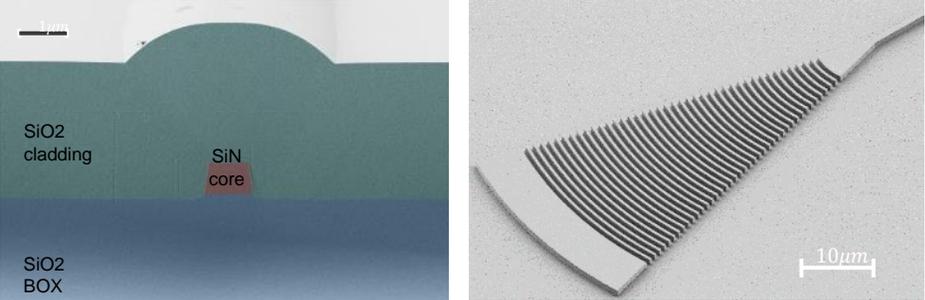
Test on glass wafer: measurements with input and output fibers (SM or MM) on adjustable micro stages



Fiber-to-fiber transmission losses measured at 0.35dB csem

# MEASURED EFFICIENCY OF THE INTERCONNECTS

Test on Si substrates with SiN waveguide with non-optimized grating couplers



Fiber-to-PIC-to-fiber measured transmission:

- 8-10 dB for the optical coupling from the SMF-28 into the input grating
- 3-5 dB per coupling into the MM G50 fibers

Intrinsic fiber-to-fiber transmission losses measured at 0.35dB

Beam quality and deflection angle as expected

Low-efficiency grating couplers to be replaced

# OUTLOOK AND APPLICATIONS

Wafer-scale fiber alignment structure for fully passive PIC packaging are intrinsically very efficient.

Demonstration with (inefficient) grating couplers and SiN waveguide.

## Packaging of electro optical devices

Self aligned fiber to device (VCSEL, photodiodes arrays)

## Interconnect to photonic integrated circuits

Self aligned fiber to chip (PIC's)

## Angled fiber to fiber interconnect

Backplane connector with enlarged alignment tolerances

## Chiplet to chiplet interconnect in a single package

Enhance the data transmission with an easy packaging

## Chip to chip interconnect

Compact on board solution

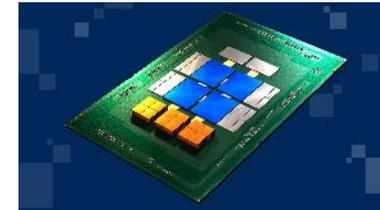
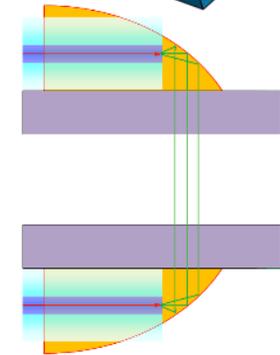
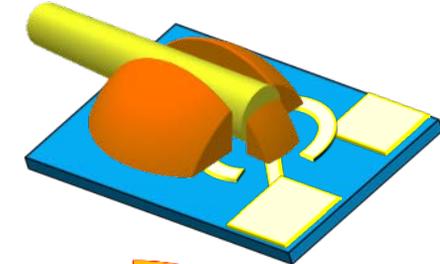
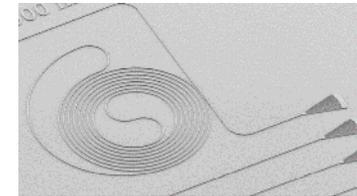
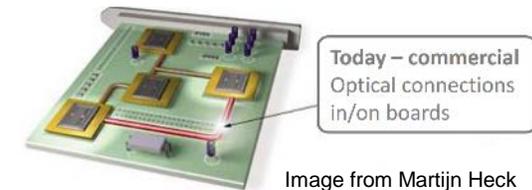


Image from Intel



Today – commercial  
Optical connections  
in/on boards

Image from Martijn Heck

**Coming in 2024: Wafer-scale micro-optics for passive assembly with (efficient) edge couplers**

# SUMMARY

- Broad set of photonic expertise, technologies & their integration
- From components to systems
- Design, prototype up to small production
- Key and unique platforms:
  - MPWs for LNOI
  - MLAs on imagers and emitters
  - Fs-laser
  - Edge & AI imagers



Even highly advanced cameras will be boosted with integrated micro-optics



Innosuisse

Enjoy the SwissPhotonics Workshop !

[info@csem.ch](mailto:info@csem.ch) - [guillaume.basset@csem.ch](mailto:guillaume.basset@csem.ch)